

Docket No.: 1592-0168PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naoharu NAKAISO

Application No.: 10/549,933

Confirmation No.: 7899

Filed: September 11, 2006

Art Unit: 1792

For: SUBSTRATE PROCESSING APPARATUS
AND SEMICONDUCTOR DEVICE
PRODUCING METHOD

Examiner: R. N. Kackar

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 3, 2008, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.